



PATENT
Attorney Docket No. MIT-168
(058420/157392)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Tuller *et al.*
SERIAL NO.: 10/646,098 GROUP NO.: 2874
FILING DATE: August 22, 2003 EXAMINER: M. R. Connelly Cushwa
TITLE: METHODS FOR FABRICATING STRAINED LAYERS ON
SEMICONDUCTOR SUBSTRATES

**RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCEDURE
ART UNIT 2874**

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE AFTER FINAL ACTION UNDER 37 C.F.R. § 1.116

Sir:

This Response is responsive to the final Office action mailed on December 5, 2005, in the above-identified patent application.

Please amend the above-identified patent application as follows, without prejudice:

- Listing of claims begins on page 2 of this paper.
- Remarks begin on page 4 of this paper.